



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 27, 2026

IGI Report Number

LG776688946

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

11.34 X 7.85 X 5.33 MM

GRADING RESULTS

Carat Weight

4.09 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG776688946

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS

Medium

67%

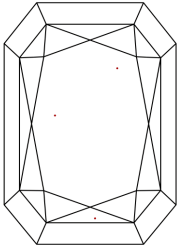
13%

51.5%

67.9%

Pointed

CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included





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11.34 X 7.85 X 5.33 MM

Carat Weight

4.09 CARATS

Color Grade

E

Clarity Grade

VVS 2

Depth

67.9%

Table

67%

Girdle

Medium

Culet

Pointed

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EXCELLENT

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Fluorescence

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